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3-10-2000



PATENT APPLICATION  
DOCKET NO. 042390.P6604

5/A  
PS  
3/23/00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Kevin J. Lee

)  
)  
)Group Art  
)Unit 1741

Serial No.:

09/223,472

Filed:

December 30, 1998

ELECTROPLATING CELL  
BASED UPON ROTATIONAL  
PLATING SOLUTION FLOW

Examiner:

Christopher Keehan

RECEIVED  
MAR 15 2000  
TC 1700 MAIL ROOM

AMENDMENT "A" AND REPLY UNDER 37 C.F.R. §1.111

Honorable Commissioner of  
Patents and Trademarks  
Washington, D. C. 20231

Sir:

In response to the Office Action mailed December 7, 1999 (the "Office Action"),  
the Applicants submit this amendment and reply.